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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kiyoshi Arita  
Serial No.: 10/762,015 Art Unit: 3742  
Filing Date: January 21, 2004  
Title: "METHOD OF MANUFACTURING SEMICONDUCTOR  
DEVICE AND CUTTING APPARATUS FOR CUTTING  
SEMICONDUCTOR WAFER"  
Docket No.: 36395

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendments  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Va. 22313-1450

Sir/Madam:

In accordance with Rule 56, applicant is aware of the publications listed in the International Search Report (copy enclosed) and in the enclosed copy of Patent Office Form 1449. A copy of each of the publications is enclosed herewith. The undersigned hereby certifies that each item of information contained in this Supplemental Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Supplemental Information Disclosure Statement.

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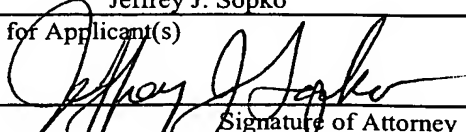
Respectfully submitted,  
PEARNE & GORDON LLP

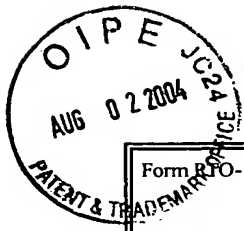
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July 29, 2004

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Name of Attorney for Applicant(s)  
07/29/2004  
Date  
  
Signature of Attorney



Form PTO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
36395SERIAL NO.  
10/762,015INFORMATION DISCLOSURE CITATION  
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(USE SEVERAL SHEETS IF NECESSARY)APPLICANT:  
Kiyoshi AritaFILING DATE:  
January 21, 2004GROUP ART UNIT:  
3742

## U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass	Filing Date If Appropriate
	A	5,693,182	12/1997	Mathuni			
	B	5,824,595	10/1998	Igel et al.			
	C	6,013,534	01/2000	Moutain			
	D	6,239,036 B1	05/2001	Arita et al.			
	E						
	F						
	G						
	H						
	I						
	J						
	K						

## FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation
	L	2 538 616	06/1984	France			English Abstract
	M						
	N						
	P						
	Q						

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	R	
	S	
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Examiner:

Date Considered

\*Examiner: Initial if reference considered, regardless of whether citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.